



*JPW*

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1792

Application No.: 10/827,426

Examiner: W. FLETCHER

Filed: April 20, 2004

Docket No.: 119295

For: CLEANING METHOD, STORAGE METHOD, PATTERN FORMATION METHOD,  
DEVICE MANUFACTURING METHOD, ELECTRO-OPTICAL DEVICE, AND  
ELECTRONIC APPARATUS

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 13, 2008 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**